Mechatronics Approach for the Development of a Nano-Active-Stabilization-System MEDSI2020, July 26-29, 2021

Dehaeze Thomas, Bonnefoy Julien and Collette Christophe

¹European Synchrotron Radiation Facility, Grenoble, France

²Precision Mechatronics Laboratory, University of Liege, Belgium

³BEAMS Department, Free University of Brussels, Belgium



Precision Mechatronics Laboratory





The ID31 Micro Station





Introduction - The Nano Active Stabilization System

Objective: Improve the position accuracy from $\approx 10\,\mu m$ down to $\approx 10\,nm$ **Design approach**: "Model based design" / "Predictive Design"



Overview of the Mechatronic Approach - Model Based Design



Outline - Conceptual Phase



Feedback Control - The Control Loop



Why Feedback?

- Model uncertainties
- Unknown disturbances

Every elements can limit the performances

- Drivers, Actuators, Sensors
- Mechanical System
- Controller

Noise Budgeting and Required Control Bandwidth



Limitation of the Controller Bandwidth?



Limitation of the Controller Bandwidth?



Limitation of the Controller Bandwidth?



Soft or Stiff ν -hexapod ? Interaction with the μ -station



Soft or Stiff ν -hexapod ? Interaction with the μ -station



Complexity of the Micro-Station Dynamics (Model Analysis)





Control Strategy: HAC-LAC



Low Authority Control

- Collocated sensors/actuators
- Guaranteed Stability
- Adds damping
- \searrow vibration near resonances

High Authority Control

- Position sensors
- Complex dynamics
- \searrow vibration in the bandwidth
- Use transformation matrices

Multi-Body Models - Simulations





Outline - Detail Design Phase



Nano-Hexapod Overview - Key elements



General Specifications

- Flexible modes as high as possible
- Only flexible elements (no backlash, play, etc.)
- Integrated Force Sensor and Displacement Sensor
- Predictable dynamics

Choice of Actuator and Flexible Joint Design

Characteristic	Specs	Doc.
Axial Stiff.	$\approx 2 N/\mu m$	1.8 N/µm
Sufficient Stroke	>100 µm	368 µm
Height	<50 mm	30 mm
High Resolution	<5 nm	3 nm



Fig.: Picture of the APA300ML

Characteristic	Specs	FEM	
Axial Stiff.	$>100 \text{ N}/\mu m$	94	
Bending Stiff.	$<\!100Nm/rad$	5	
Torsion Stiff.	<500 Nm/rad	260	
Bending Stroke	>1 mrad	20	



Fig.: Picture of the joint

Instrumentation





Characteristics	Manual
Gain	20
Noise	0.7 mV rms
Small Signal BW	7.4 kHz
Large Signal BW	300 Hz



Fig.: Renishaw - Vionic Encoder

Characteristics	Manual
Range Resolution Sub-Divisional Error Bandwidth	Ruler length 2.5 nm $<\pm15$ nm >5 kHz



Fig.: Speedgoat - Target Machine

Characteristics	Manual
ADC (×16) DAC (×8) Digital I/O (×30) Sampling Freq.	$egin{array}{llllllllllllllllllllllllllllllllllll$

All elements could be chosen/design based on the models

Outline - Experimental Phase



Flexible Joints - Measurements







Amplified Piezoelectric Actuator - Test Bench



Amplified Piezoelectric Actuator - Extracted Model



Amplified Piezoelectric Actuator - Integral Force Feedback



21/30

Strut - Mounting Tool





Strut - Dynamical Measurements



Goals

- Identify Dynamics
- Tune Model
- Flexible joints effects
- Encoder effect



Strut - Encoders Output and Spurious Modes









Nano-Hexapod Mounting Tool





Mounted Nano-Hexapod



Nano-Hexapod - Identified Dynamics



Nano-Hexapod - Damped Dynamics



The Nano-Hexapod on top of the Micro-Station



The Nano-Hexapod on top of the Micro-Station



Conclusion

Mechatronics Approach:

- Use of several models
- Predictive design
- Beneficial in terms of: cost, delays, performances

Future Work:

- Optimal/Robust control
- Control Test Bench
- Implementation on ID31

Many thanks to

Philipp Brumund, Ludovic Ducotte Jose-Maria Clement, Marc Lesourd



Youness Benyakhlef, Pierrick Got Damien Coulon and the whole team